

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: To Be Assigned

Examiner: To Be Assigned

In Re PATENT APPLICATION OF:

Applicant : Shinichi Kohda

U.S. Appln. No. : To Be Assigned

International Appln. No.: PCT/JP04/016872

International Filing Date: November 12, 2004

Priority Date Claimed : November 12, 2003

For : SEMICONDUCTOR LASER AND
METHOD FOR MANUFACTURING
THE SAME

Attorney Ref. : KAW 131NP

**INFORMATION
DISCLOSURE
STATEMENT**

May 8, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

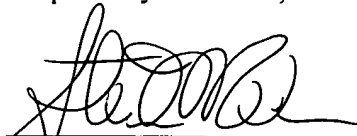
Sir:

This is an Information Disclosure Statement submitted in compliance with the timing requirements of 37 C.F.R. § 1.97(b)(2).

Attached are copies of three Japanese patent publications, any relevance of which to the claimed invention can be gleaned from the attached English-language Abstracts, the attached English-language international search report, and/or discussion on page 2 of the specification. All of the publications are listed on the attached Form PTO-1449.

Since this Information Disclosure Statement is being filed with the application, no certification or fee is required, and the requirements of 37 C.F.R. §§ 1.97 and 1.98 are deemed to be fully met as to all documents listed. Consideration of the listed documents is respectfully requested.

Respectfully submitted,



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May 8, 2006

Date

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